

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

(substitute form 1449A)

Sheet 1 of 1

Application Number: 09/810,825

Filing Date: March 16, 2001

First Named Inventor: MAO et al.

Group Art Unit: unassigned

Examiner Name: unassigned

U.S. Patent Documents

Examine r Initials	Cite No.	Document No.	Name of Applicant	Date	Class	Sub- class	Filing Date (if appropriate)
ht	1	6,303,885	Hichwa et al.	10/16/01	200	181	
ht	2	6,229,683	Goodwin-Johansson	05-2001	361	233	
ht	3	6,160,230	McMillan et al.	12-2000	200	181	
ht	4	6,058,027	Vargha et al.	05-2000	363	33	
ht	5	6,046,659	Loo et al.	04-2000	333	262	
ht	6	5,998,906	Jerman et al.	12/07/99	310	309	
ht	7	5,995,688	Aksyuk et al.	11/30/99	385	14	
ht	8	5,994,816	Dhuler et al.	11/30/99	310	307	
ht	9	5,955,817	Duhler et al.	09/21/99	310	307	
ht	10	5,943,454	Aksyuk et al.	08/24/99	385	22	
ht	11	5,923,798	Aksyuk et al.	07/13/99	385	19	
ht	12	5,909,078	Wood et al.	06/01/99	310	307	
ht	13	5,629,565	Schlaak et al.	05-1997	257	780	
ht	14	5,594,820	Garel-Jones et al.	01/14/97	385	22	
ht	15	5,519,240	Suzuki	04-1996	257	315	
ht	16	5,025,346	Tang et al.	06/18/91	361	283	

FOREIGN PATENT DOCUMENTS

		Office	Number	Kind	Name of Applicant	Date of Publication	English Translation
ht	17	EP	1 004 910		Jin	11/16/99	Yes
ht	18	PCT	WO 98/12589		Anthamatten	03/26/98	Yes
ht	19	DE	3644802		Schmitt	07/14/88	no
ht	20	EP	0 880 040		Aksyuk	05/15/97	Yes
ht	21	JP	6-148536		Sumitomo Electric Ind Ltd	05-1994	

U.S. Patent Applications

Examiner's Initials	Cite No.	App. Ser. No.	Applicant	Filing Date
by	22	09/517,913	Hichwa et al.	March 3, 2000

OTHER ART

by	23	Marxer and de Rooij, MICRO-OPTO-MECHANICAL 2X2 SWITCH FOR SINGLE-MODE FIBERS BASED ON PLASMA-ETCHED SILICON MIRROR AND ELECTROSTATIC ACTUATION, IEEE J. of Lightwave Technology, Vol. 17, No. 1, 2-8 (January 1999)
by	24	Lee et al., BI-STABLE PLANAR POLYSILICON MICROACTUATORS WITH SHALLOW ARCH-SHAPED LEAF SPRINGS, SPIE Conference on Micromachined Devices and Components V, 274-279 (September 1999), Santa Clara, California
by	25	Chen et al., A HIGH-SPEED LOW-VOLTAGE STRESS-INDUCED MICROMACHINED 2X2 OPTICAL SWITCH, IEEE Photonics Technology Letters, Vol. 11, No. 11, 1396-1398 (November 1999)
EXAMINER		DATE CONSIDERED

[Signature] 10/30/02



(substitute form 1449A)

Examiner Name: unassigned

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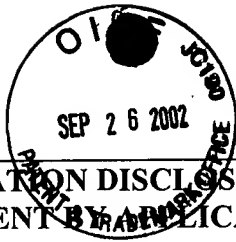
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EXAMINER		DATE CONSIDERED	
W. J. T.		12/20/22	



INFORMATION DISCLOSURE STATEMENT BY APPLICANT (substitute form 1449A)	Application Number: 09/810,825
	Filing Date: March 16, 2001
	First Named Inventor: Mao
	Group Art Unit: 2834
Sheet 1 of 1	Examiner Name: Tamai, K.

U.S. Patent Documents

Examiner Initials	Cite No.	Document No.	Name of Applicant	Date	Class	Sub- class	Filing Date (if appropriate)
WT	27	5,808,384	Tabat et al.	09/15/98	310	40	
WT	28	6,388,359	Duelli et al.	05/14/02	310	309	

Published U.S. Patent Applications

FOREIGN PATENT DOCUMENTS

	Office	Number	Class	Name of Applicant (1 st inventor)	Date of Publication	English Translation

OTHER ART

EXAMINER	K. Tamai		DATE CONSIDERED 10/28/12